

Notice of References Cited	Application/Control No. 10/689,042		Applicant(s)/Patent Under Reexamination PATEL	
	Examiner Anita K. Alanko		Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Zeidler, D. et al "The interaction between different barrier metals and the copper surface during the chemical-mechanical polishing" Microelectronic Engineering, 1997, 37/38, 237-243.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.